



**PATENT**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

**DN 51473**

In re application of:  
Gallagher et al.

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Serial No.: 10/661,051

:

Filed: September 13, 2003

: Group Art Unit: 1765

For: AIR GAP FORMATION

: Examiner: Kin Chan Chen

**RESPONSE AFTER FINAL**

Mail Stop AF  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 2313-1450

In response to the Official Action mailed on November 29, 2005, Applicants request entry of the following remarks.

Remarks begin on page 2 of this paper.

*Do not enter  
(declaration 1.132).*

*K-cc 3/13/06*